TO THE STORY OF COMMISSION				ATTY DOCKET NO.		SERIAL NO.			
Form PTO 1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			248760US0RDCONT	New Continuation of 10/188,744					
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LIST OF	REFE	RENCES CITED BY API	PLICANT	Yasuo OHBA					
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		TRADEN	ST. OF	U.S. PATENT DOCUMENTS					
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE		
	AA	4,792,958	12/20/88	OHBA, et al.					
	AB	4,809,287	02/28/89	OHBA, et al.					
	AC	4,835,117	05/30/89	OHBA, et al.		K 1 1 7 - 7			
	AD	4,949,349	08/14/90	OHBA, et al.					
	AE	4,910,743	03/20/90	OHBA, et al.					
	AF	4,928,285	05/22/90	KUSHIBE, et al.					
	AG	4,893,313	01/09/90	HATAKOSHI, et al.					
	AH	5,076,800	12/31/91	MILNES, et al.					
	Al	5,036,521	07/30/91	HATAKOSHI, et al.					
	AJ	5,168,077	12/01/92	ASHIZAWA, et al.					
	AK	5,042,043	08/20/91	HATANO, et al.					
	AL	5,005,057	04/02/91	IZUMIYA, et al.					
	AM	5,079,184	01/07/92	HATANO, et al.					
	AN	5,103,271	04/07/92	IZUMIYA, et al.					
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LIST OF	REFE	RENCES CITED BY	VPPLICANT		Yasuo OHB	Α	
				FILING DATE	GROUP		
				July 5, 2002			2811
				U.S. PATENT DOCUMENTS			
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING D IF APPROP
The second	AA	6,242,764	06/05/2001	Y. OHBA, et al.			
acel.	AB	5,990,495	11/23/99	Y. OHBA			
New York	AC	5,656,832	08/12/97	Y. OHBA, et al.			
1912	AD	5,909,040	06/01/99	Y. OHBA, et al.			
2002	AE	5,929,466	07/27/99	Y. OHBA, et al.			
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